

**PATENT APPLICATION**  
**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q92479

Tsuyoshi UEHARA, et al.

Appln. No.: 10/565,004

Confirmation No.: 5166

Group Art Unit: 1792

Filed: January 19, 2006

Examiner: Keath T CHEN

For: PLASMA PROCESSING APPARATUS AND ELECTRODE STRUCTURE

**AMENDMENT UNDER 37 C.F.R. § 1.114(c)**

**MAIL STOP RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated July 1, 2008, please amend the above-identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

AMENDMENTS TO THE SPECIFICATION .....	2
AMENDMENTS TO THE CLAIMS .....	3
REMARKS .....	19